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Application/Control No.	Applicant(s)/Patent under Reexamination	_
10/020,529	DAVIE ET AL.	
Examiner	Art Unit	
Pierre-Louis Desir	2681	

	SEARCHED			
Class	Subclass	Date	Examiner	
455	550.1	4/11/2005	PD	
379	446	9/9/2005	PD	
379	118	9/9/2005	PD	
455	. 575.9	9/9/2005	PD	
D14	253	9/9/2005	pd	
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INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
455	550.1	4/11/2005	PD
379	446	9/9/2005	PD
455	575.6	9/9/2005	PD
see attac	hed sheet	9/9/2005	PD

SEARCH NOT (INCLUDING SEARCH		)
	DATE	EXMR
EAST	4/11/2005	PD
Jack Chiang	9/9/2005	PD
EAST	9/9/2005	PD